

IN THE U.S. PATENT AND TRADEMARK OFFICE

2342-0107P

Applicant: HIRANO, Mitsuhiro
 Application No.: 08/813,200
 Filed: March 7, 1997
 For: SUBSTRATE PROCESSING APPARATUS



Group: 1104

Examiner:

STATUS INQUIRY

Assistant Commissioner for Patents
 Washington, D.C. 20231

October 29, 1998

Sir:

Please advise the undersigned as to the status of the above-identified application.

A duplicate copy of the present Status Inquiry is attached hereto. It is respectfully requested that the duplicate copy be marked appropriately to indicate the status of the above-identified application, and returned to the undersigned as soon as possible.

Please call the undersigned at (703) 205-8000 if there are any questions with regard to the present request.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By:

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_____ Awaiting Action from Patent Office Examiner:

 _____ Awaiting Decision by Board of Appeals.
 _____ Application allowed on _____.
 _____ Abandoned per _____.
 _____ Other _____
